## Certification under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is each being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to The Commissioner for Patents, Washington, D.C. 20231 on February 17, 2003.

Vangelis Economou

Name

Signature Signature

DOCKET: CU-2636

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

APPLICANT: Sang lck LEE et al

SERIAL NO: 09/994,284

Group Art Unit: 2823

FILING DATE: November 26, 2001 ) Examiner:

Pham, Thanh V

TITLE: METHOD OF FORMING METAL GATE IN )

SEMICONDUCTOR DEVICE

The Commissioner for Patents Washington, D.C. 20231

## REQUEST FOR ONE MONTH EXTENSION

Dear Sir:

With reference to the Final Office Action dated October 15, 2002, applicant respectfully requests a one month extension of the term for response, from the present term of January 15, 2003 up to a new term of February 15, 2003.

Enclosed is check in the amount of \$110 to cover the fee for this one month extension. Should any additional fee be deemed necessary, the Commissioner is authorized to charge our Deposit Account No. 12-0400.

Respectfully submitted,

February 17, 2003

Date

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Attorney for Applicant

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c/o Ladas & Parry 224 South Michigan Avenue Chicago, Illinois 60604

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